



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

#9 / Assoc
P/atty

In re Application of:

Gurtej S. Sandhu

Serial No.: 09/023,146

Filed: February 12, 1998

For: TUNGSTEN SILICIDE (WSIx)
DEPOSITION PROCESS FOR
SEMICONDUCTOR MANUFACTURE

Examiner: T. Dang

Group Art Unit: 2823

Attorney Docket No.: 3369US
(91-365-RE)

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Sir:

In accordance with 37 C.F.R. § 1.34(b), please recognize the following individual as an associate agent/attorney herein in connection with the above-identified patent application:

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Respectfully submitted,

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